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Paul Shirley et al.

[illegible]

Group Art Unit: 2823

Examiner: Toledo, Fernando L.

**For: METHOD AND APPARATUS
FOR A TWO-STEP RESIST SOFT
BAKE TO PREVENT ILL
OUTGASSING DURING
SEMICONDUCTOR PROCESSING**

Atty. Docket: MICS:0117/FLE/FAR
02-1051

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

August 29, 2005

Date _____

MOZ

Michael G. Fletcher

**RESPONSE TO RESTRICTION REQUIREMENT
MAILED JULY 29, 2005**

In response to the Office Action mailed July 29, 2005, please amend the above-identified application as follows: